

Supporting Information

Residue-Driven Degradation and Its Stabilization in NaCl-Assisted WS₂ with 3R Stacking Enrichment

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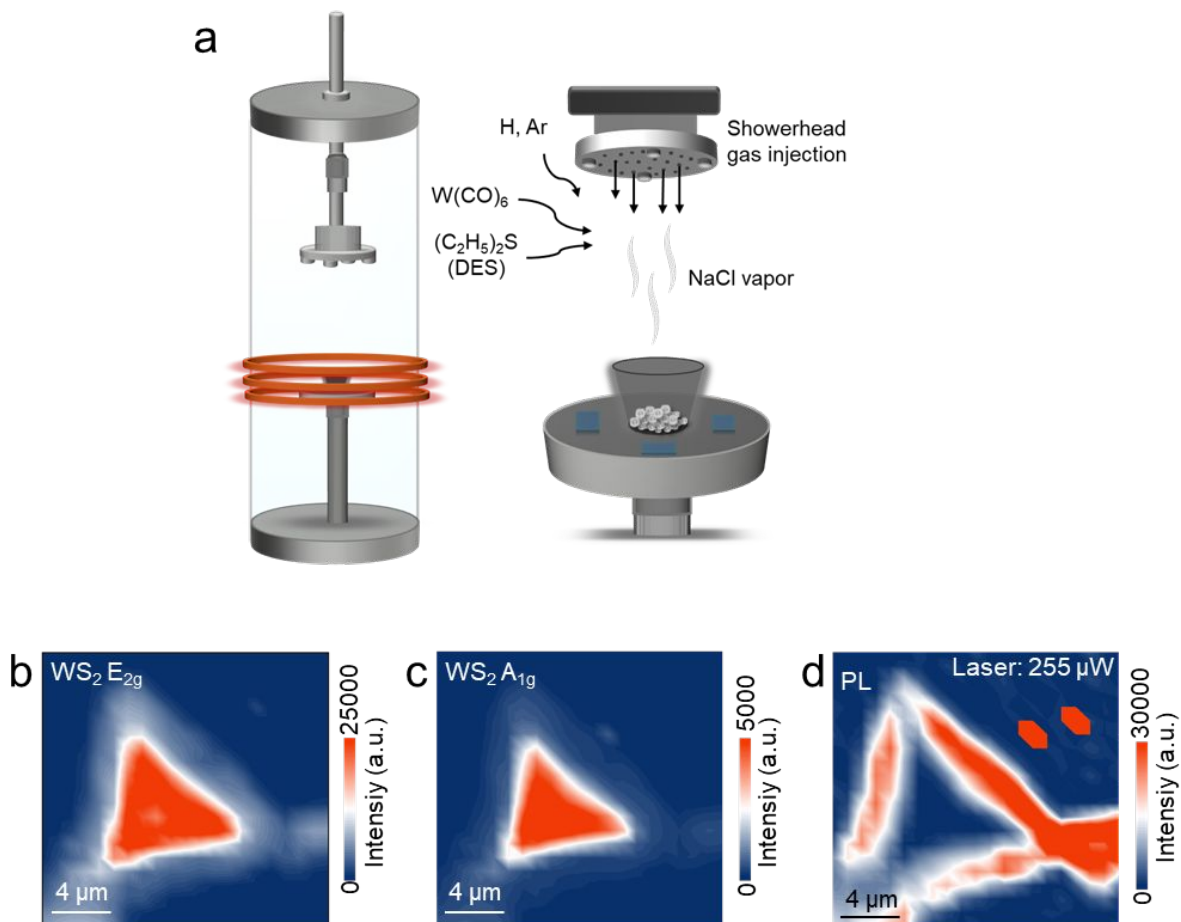


Figure S1. (a) Schematic of the vertical MOCVD process used for NaCl-assisted WS₂ growth on SiO₂/Si. (b,c) Raman E_{2g} and A_{1g} intensity maps of a representative as-grown triangular WS₂ flake. (d) PL intensity map of the same flake.

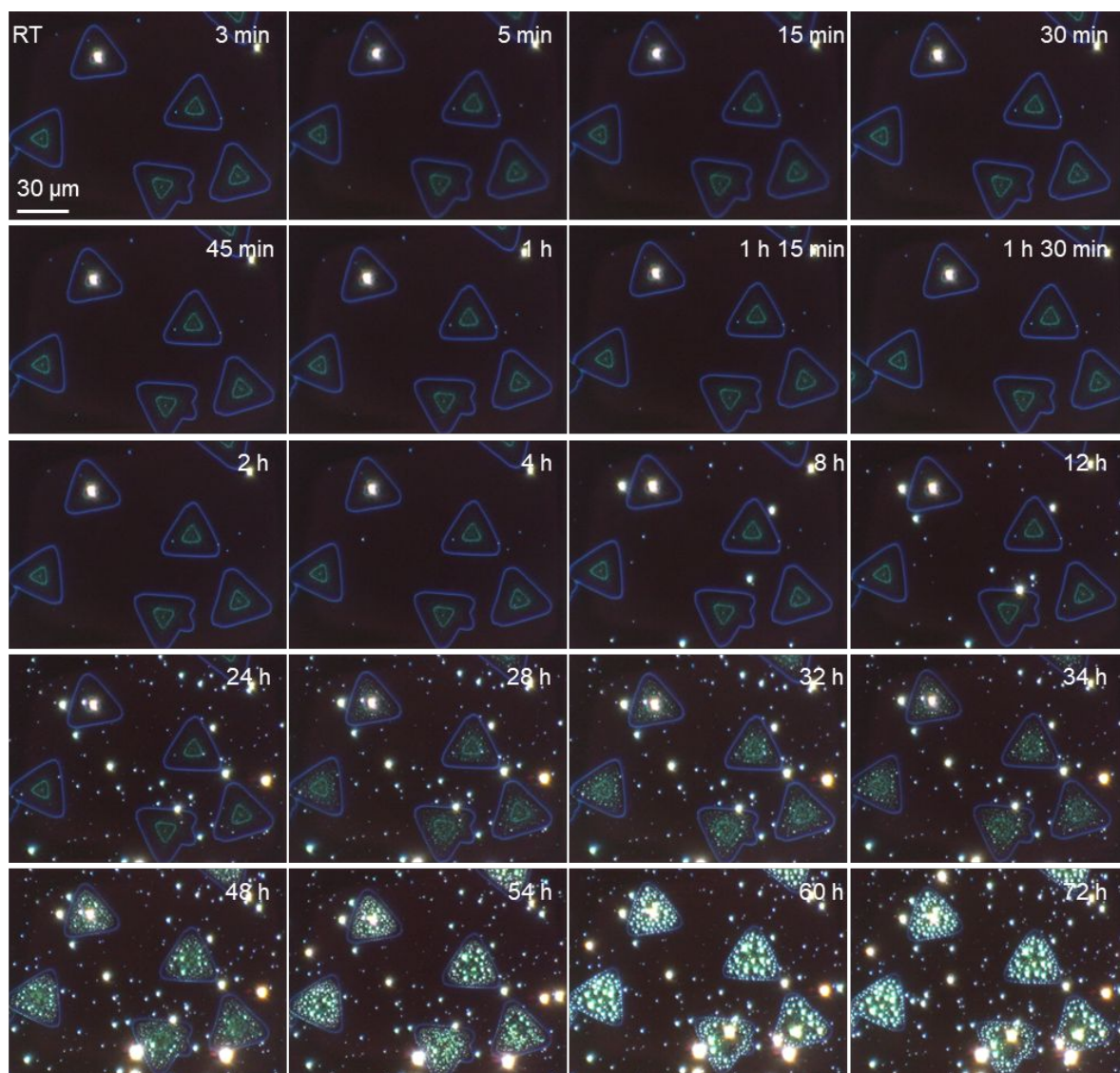


Figure S2. (a) Dark-field optical microscopy images of representative as-grown WS₂ flakes recorded during ambient air exposure from 3 min to 72 h.

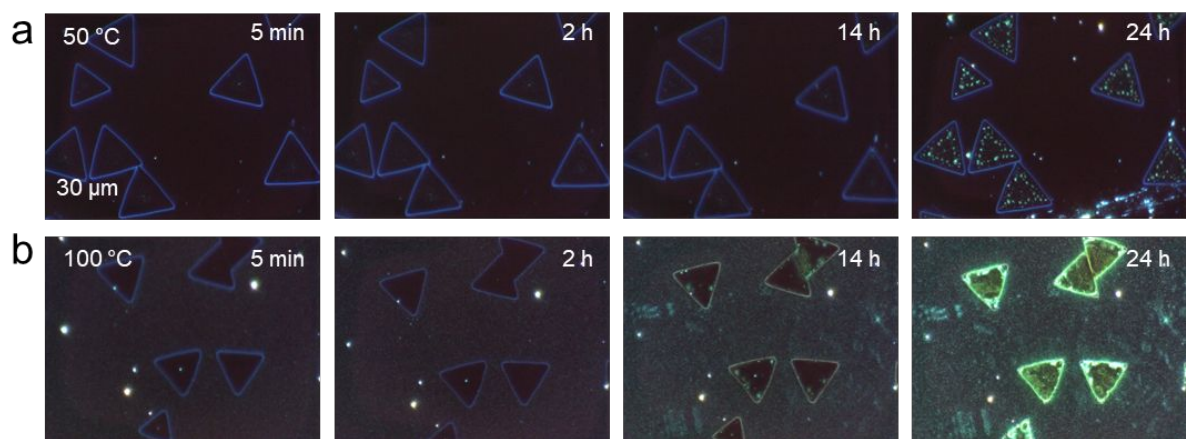


Figure S3. (a–b) Dark-field optical microscopy images of as-grown NaCl-assisted WS₂ recorded during ambient air exposure at 50 °C and 100 °C, respectively, showing the time-dependent degradation at elevated exposure temperatures.

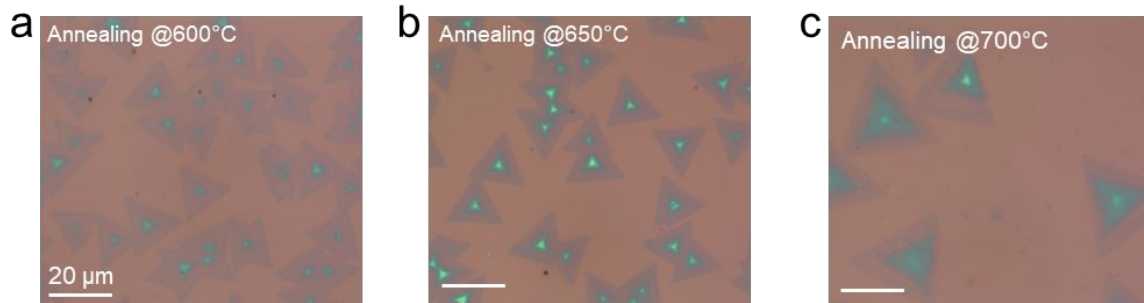


Figure S4. (a–c) Optical microscopy images of representative NaCl-assisted WS₂ flakes after PGA at 600, 650, and 700 °C, respectively, under otherwise identical sulfur-rich conditions, imaged after 1 day of ambient air exposure. The 650 °C condition (b) retains a well-defined triangular morphology after exposure, whereas residual post-exposure damage remains at 600 °C (a) and thermally induced morphological degradation is observed at 700 °C (c).

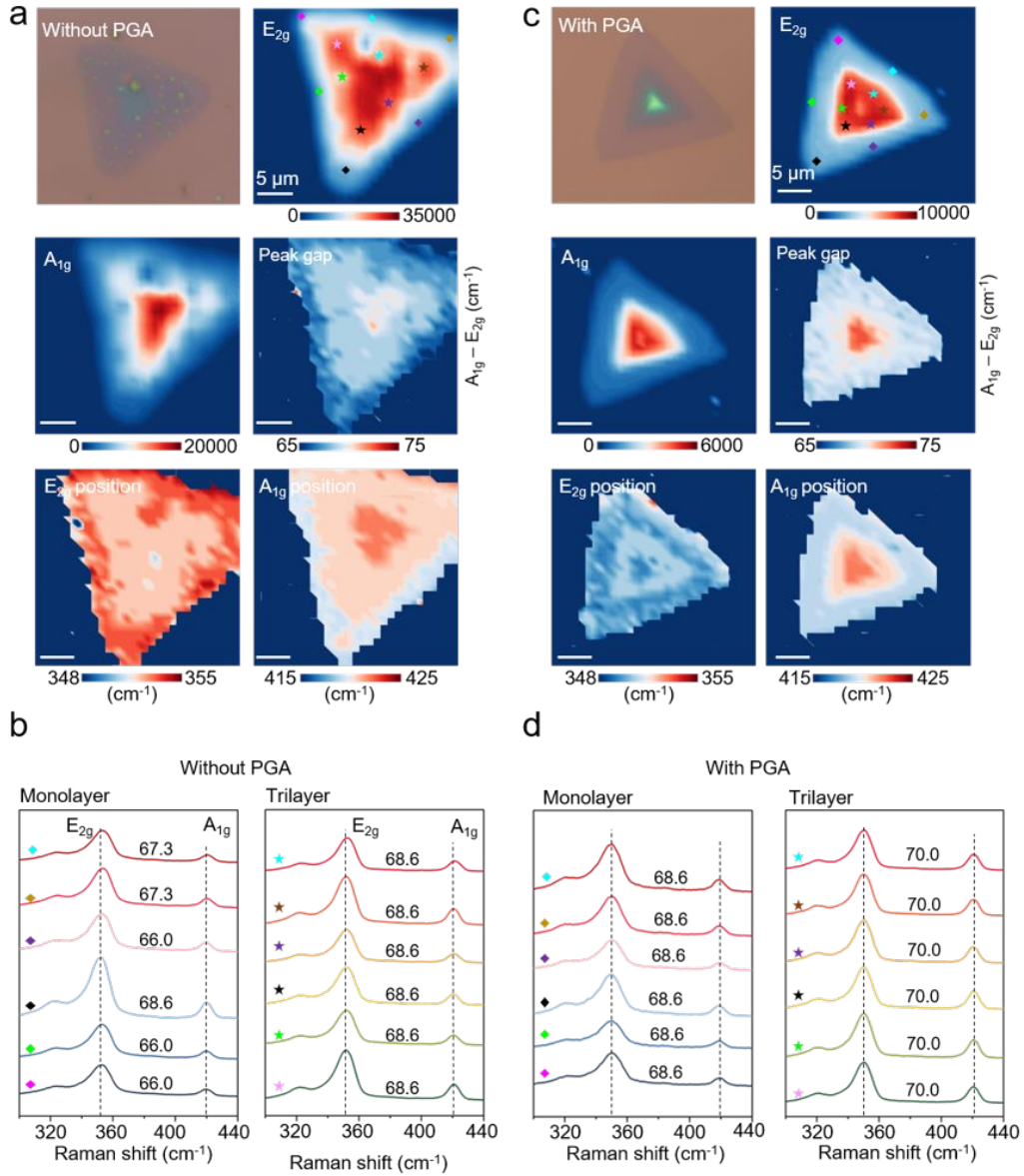


Figure S5. Spatially-resolved Raman analysis of NaCl-assisted WS₂ before and after PGA. (a) Optical microscopy image and corresponding E_{2g} intensity, A_{1g} intensity, peak gap $\Delta\omega = \omega_{A_{1g}} - \omega_{E_{2g}}$, E_{2g} position, and A_{1g} position maps without PGA. (b) Representative Raman point spectra from monolayer and trilayer positions marked in panel a. (c) Corresponding maps of PGA-treated WS₂ with identical layout to panel a. (d) Representative Raman point spectra from monolayer and trilayer positions marked in panel c. Colored symbols correspond to sampling positions in the respective E_{2g} intensity maps.

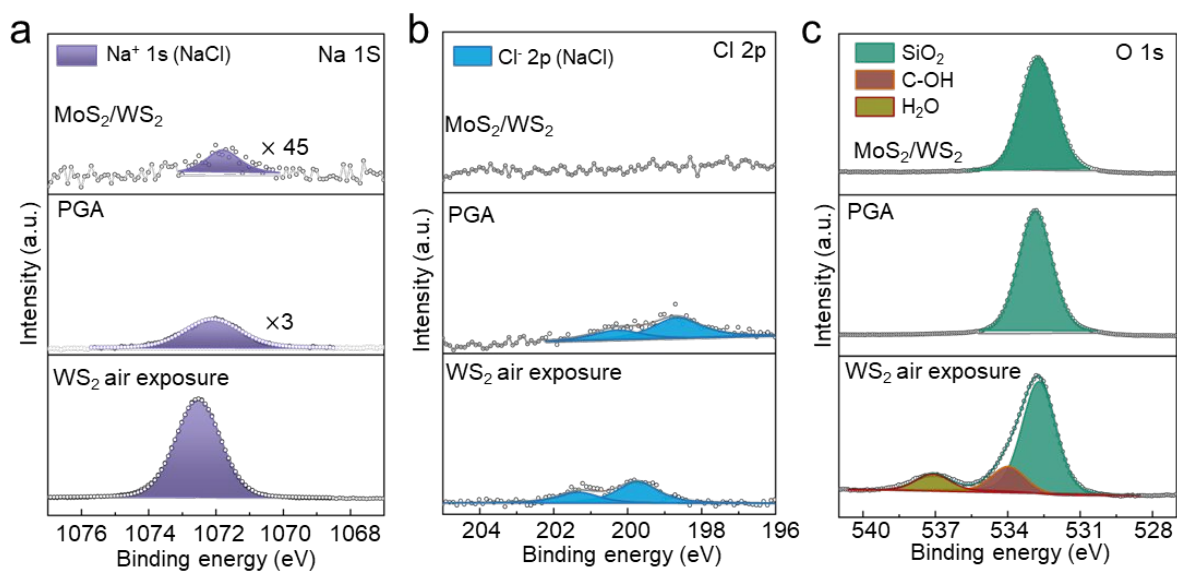


Figure S6. (a) Na 1s, (b) Cl 2p, and (c) O 1s XPS spectra of air-exposed, PGA-treated, and MoS₂-capped WS₂ samples.

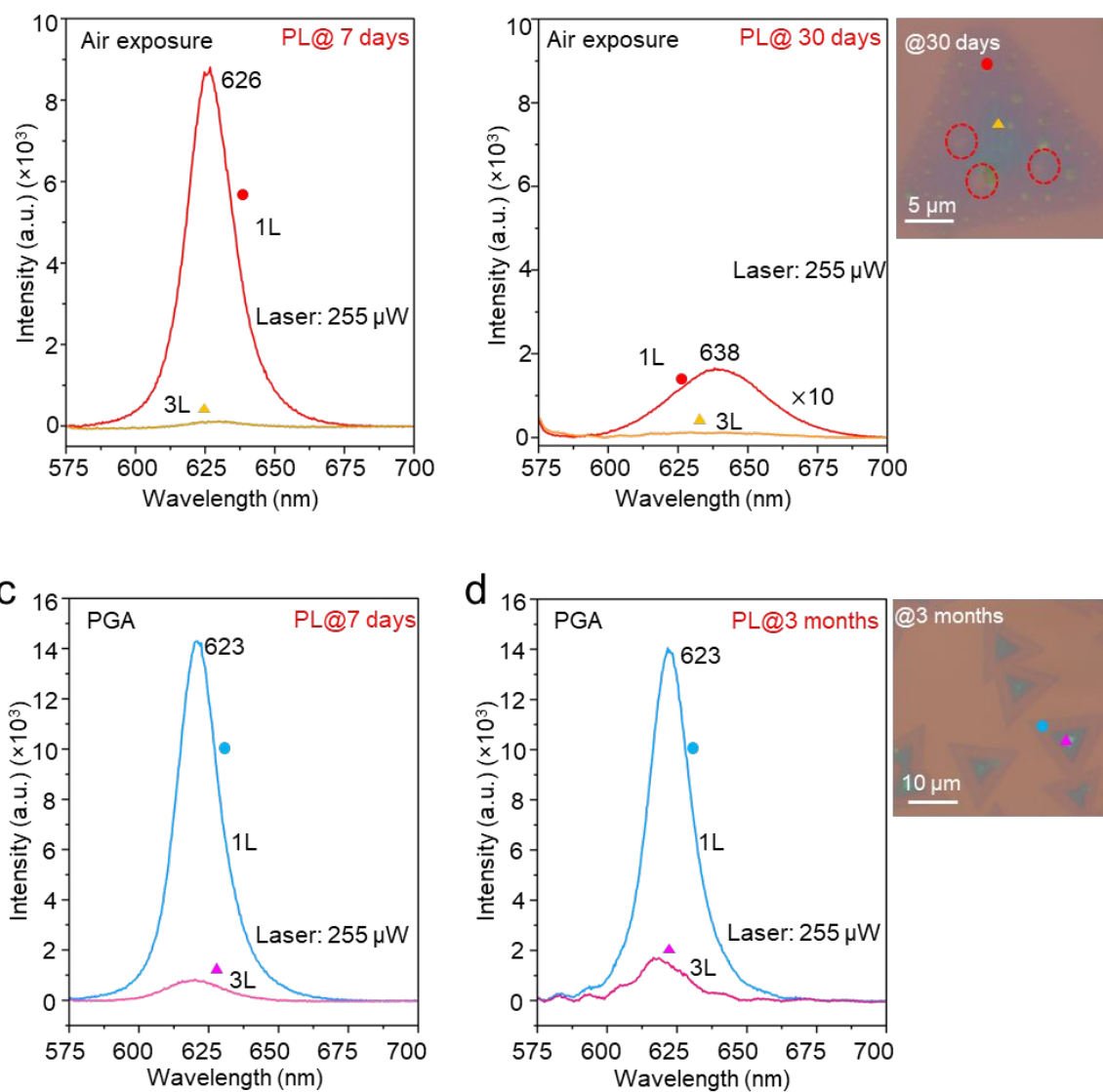


Figure S7. (a,b) PL spectra from representative 1L and 3L regions of an air-exposed as-grown NaCl-assisted WS₂ flake after 7 and 30 days, respectively, with corresponding the optical images. (c,d) PL spectra from representative 1L and 3L regions of a PGA-treated flake after 7 days and 3 months, respectively, with corresponding optical images.

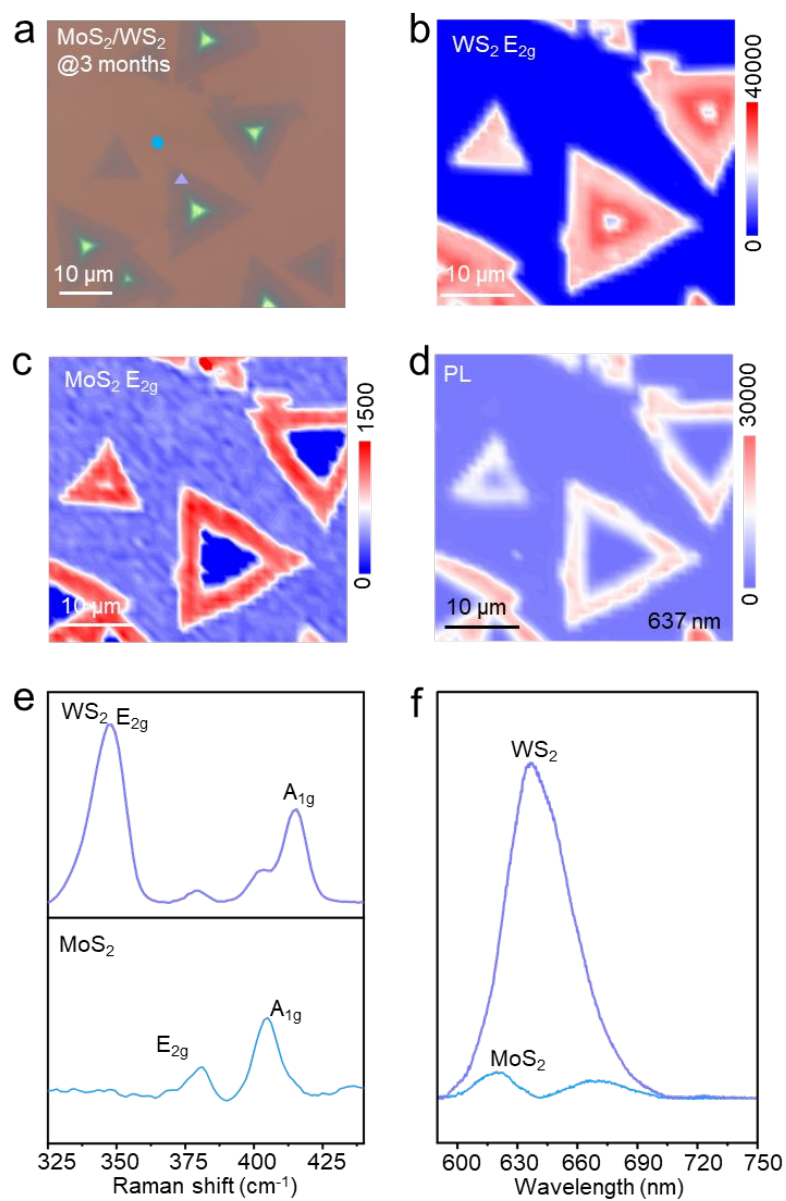


Figure S8. (a) OM image of representative MoS₂/WS₂ heterostructure flakes after 3 months of ambient storage. (b,c) Raman intensity maps of the WS₂ E_{2g} and MoS₂ E_{2g} modes. (d) PL intensity map at 637 nm. (e,f) Representative Raman and PL spectra from the marked positions in (a).

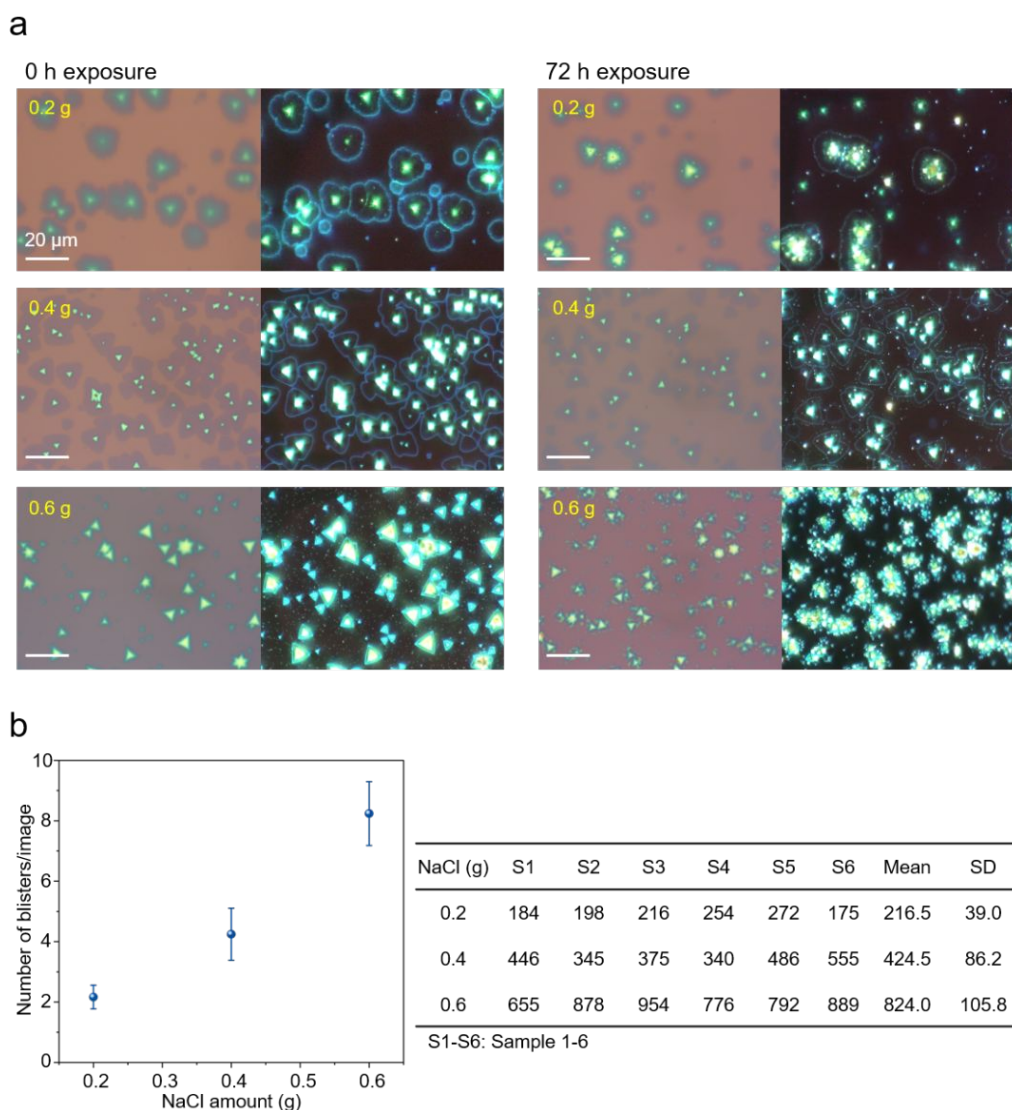


Figure S9. Effect of NaCl loading on WS₂ growth morphology and residue-driven protrusion formation. (a) Bright-field and dark-field optical microscopy images of NaCl-assisted WS₂ grown with 0.2, 0.4, and 0.6 g NaCl before (0 h) and after (72 h) ambient air exposure. With increasing NaCl loading, flake morphology evolves from poorly defined, rounded domains (0.2 g) to well-defined triangular flakes (0.6 g), with correspondingly increased protrusion density in dark-field. (b) Protrusion density after 72 h exposure as a function of NaCl loading amount. Data points represent mean $\pm$ standard deviation (N = 6 independent image regions per condition; image area:

112 μm $\times$ 84 μm ; blister count $\times 10^2$ per image). Individual counts and summary statistics (mean $\pm$ SD) for all six regions are provided in the accompanying table.

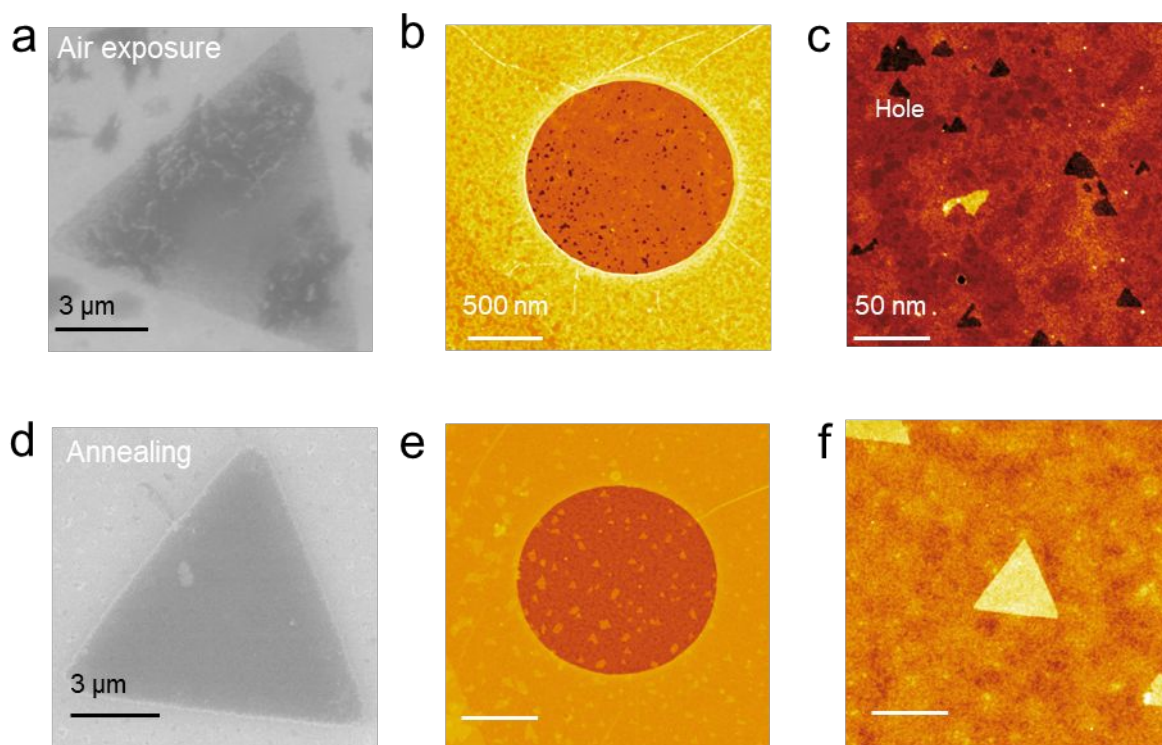


Figure S10. (a,d) SEM images of the air-exposed as-grown and PGA-treated samples, respectively. (b,c) STEM images of representative bilayer regions from the air-exposed sample. (e,f) STEM images of representative bilayer regions from the PGA-treated sample.

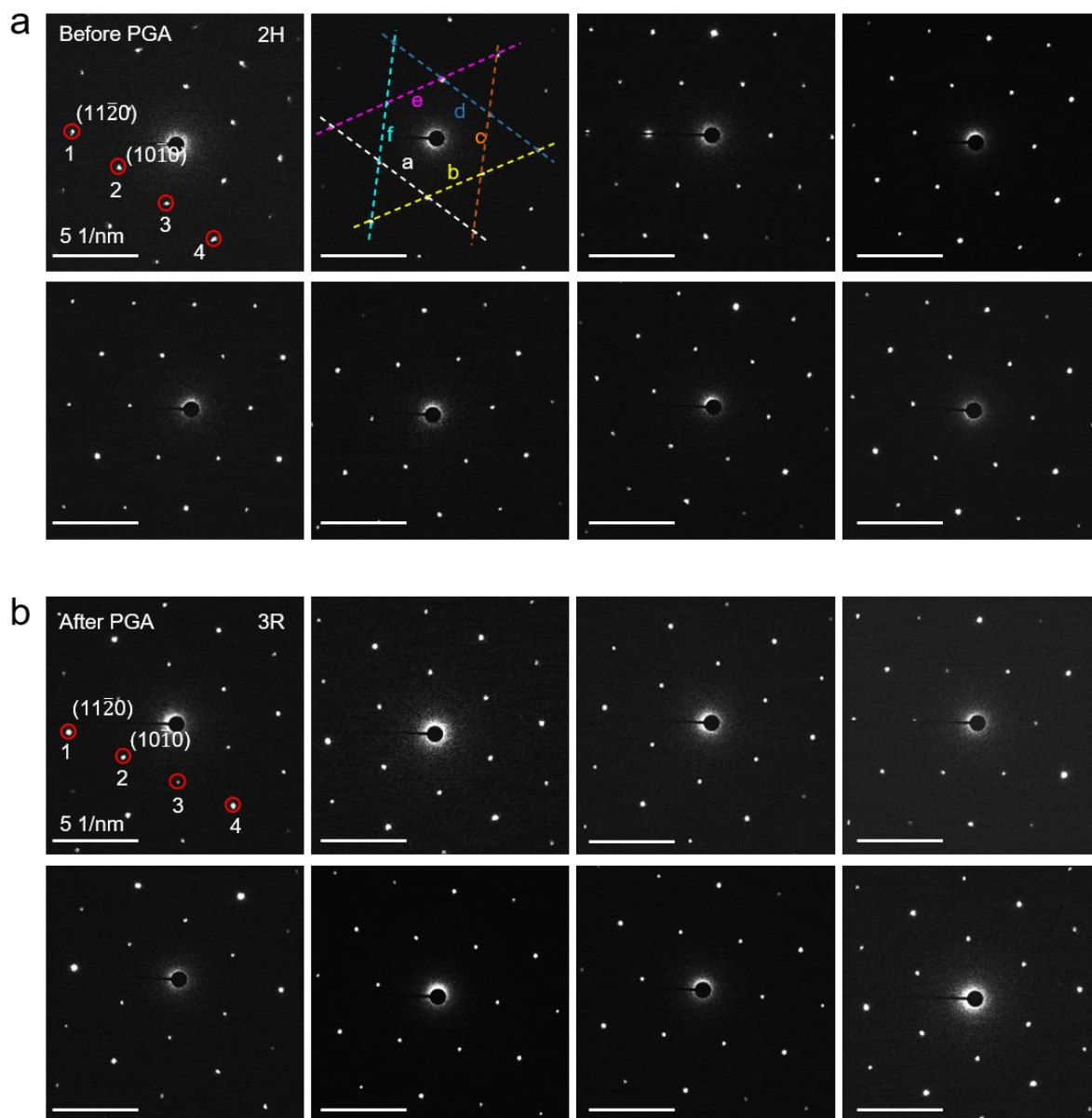


Figure S11. SAED patterns used for stacking-statistics analysis. (a, b) Representative SAED patterns collected from multilayer WS_2 regions before PGA (a) and after PGA (b). For each condition, $N = 10$ independent multilayer regions were analyzed; 8 representative patterns are shown here, with the remaining 2 presented in Figure 4 and Figure 5. For each pattern, the inner/outer diffraction-spot intensity ratio ($I^{\text{inner}}/I^{\text{outer}}$) was measured along six crystallographic

line profiles, from two symmetry-equivalent spot pairs corresponding to the $\{10\bar{1}0\}$ and $\{11\bar{2}0\}$ reflections, and averaged into a single representative ratio per region.

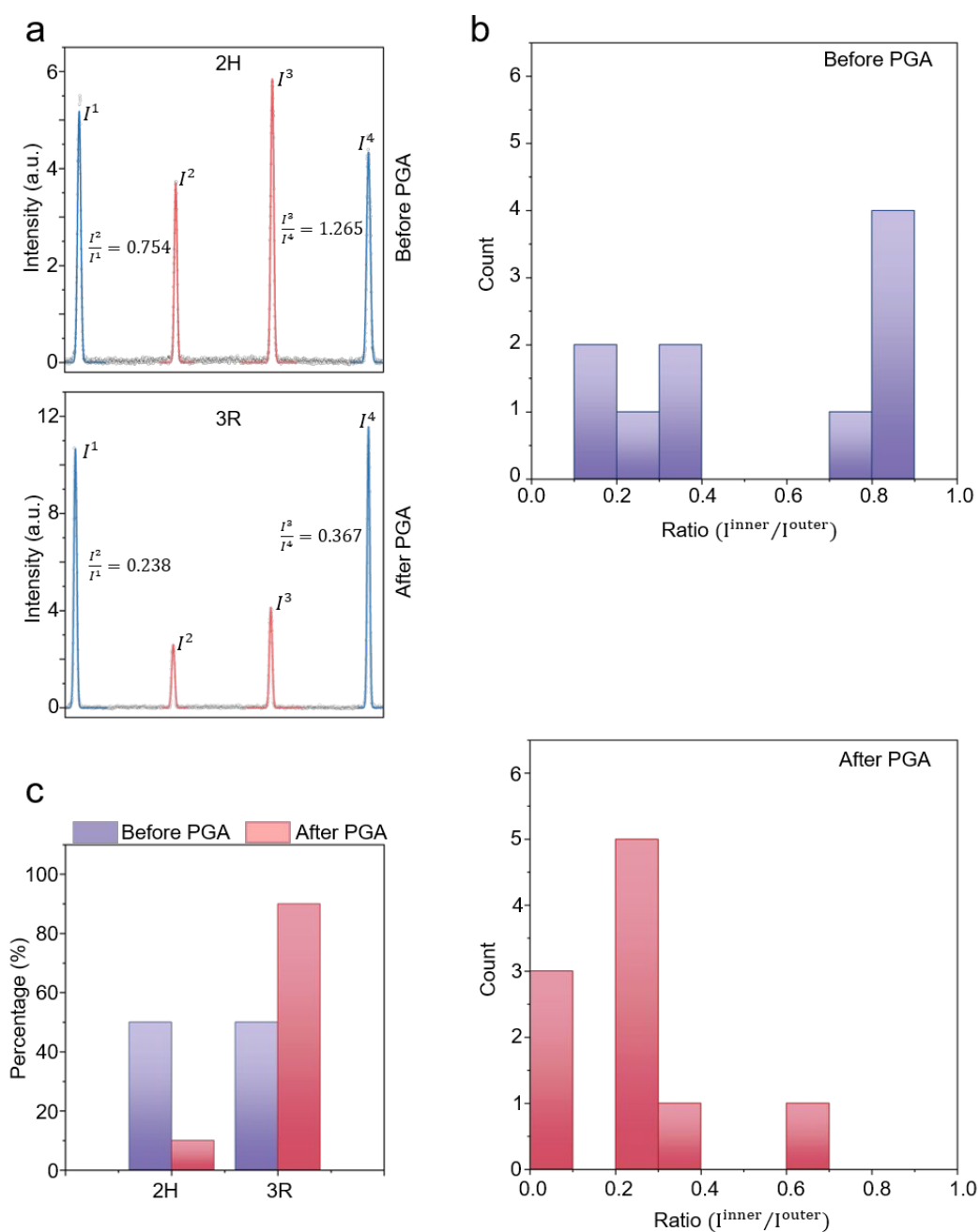


Figure S12. Statistical analysis of 2H and 3R stacking before and after PGA. (a) Representative spot-intensity profiles for 2H- and 3R-stacked bilayer WS_2 . (b) Histograms of region-averaged $I^{\text{inner}}/I^{\text{outer}}$ ratio ($N = 10$ independent regions per condition) before and after PGA. (c) Percentage of 2H- and 3R-classified regions before and after PGA, based on the region-averaged ratios shown in (b), with each region classified as 3R (≤ 0.45) or 2H (> 0.45).

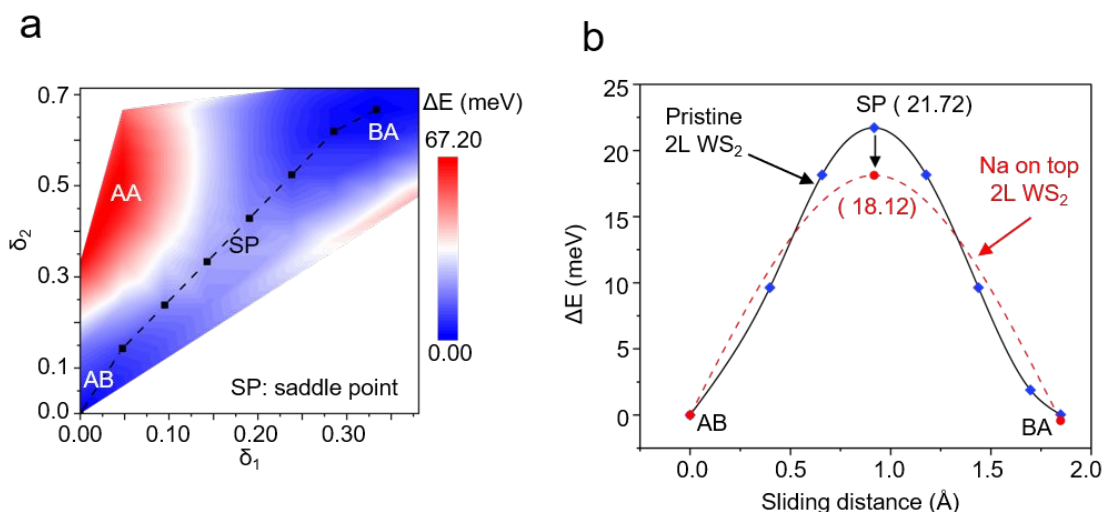


Figure S13. Generalized stacking fault energy (GSFE) analysis of interlayer sliding in bilayer WS_2 . (a) Two-dimensional GSFE map computed over 62 displacement points on the primitive cell using a rigid-sliding protocol, covering the AB $\rightarrow$ BA sliding corridor; energies range from 0 meV at the AB and BA minima to ~ 67 meV at the boundary of the sampled region. The dashed line indicates the minimum-energy path connecting AB and BA through the saddle point (SP); the AA configuration (global maximum, 221 meV per unit cell) lies outside the sampled region. (b) One-dimensional GSFE profiles along the minimum-energy path for pristine bilayer WS_2 (black) and a 4×4 supercell with one Na atom adsorbed on the top WS_2 surface (red dashed). Surface Na reduces the interlayer sliding barrier from 21.72 meV (pristine) to 18.12 meV ($\sim 16\%$ reduction).